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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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ART UNIT: 2825

APPLICANTS: Neil J. Bassom et al.

EXAMINER: Renzo Rocchegiani

FILING DATE: January 23, 2002

TITLE: Fabrication of High Resistivity Structures Using Focused Ion Beams

REQUEST FOR ONE-MONTH EXTENSION OF TIMEAssistant Commissioner for Patents
Washington, D.C. 20231

Applicants request that the time for responding to the September 23, 2003 Office action be extended one month to January 23, 2004. The Office is hereby authorized to charge the \$110.00 extension fee and any other fees associated with this filing to Deposit Account 50-01635. A duplicate copy of this authorization is attached.

Respectfully submitted,

Date: 12-24-03

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CERTIFICATE OF FACSIMILE

I hereby certify that this paper or fee is being transmitted via facsimile 01-703-872-9306 to the Assistant Commissioner for Patents, (TC2800) Washington, D.C. 20231, December 24, 2003.

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